Electronic Patent Application Fee Transmittal

Application Number:	10779397
Filing Date:	13-Feb-2004
Title of Invention:	Substrate processing apparatus and substrate processing method
First Named Inventor/Applicant Name:	Naoki Shindo
Filer:	David Tai-Wei Yang/Deanna Fintz
Attorney Docket Number:	199372003910

Filed as Large Entity

Utility under 35 USC 111(a) Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD($)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 2 months with $0 paid	1252	1	490	490

Description	Fee Code	Quantity	Amount	Sub-Total in USD($)
Miscellaneous:				
		Total in USD ($)		**490**